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conductor and transparent top electrode to expose a portion of the electrically conductive metal substrate. The exposed metal serves as a contact area for interconnecting adjacent cells. These material removal techniques are troublesome for a number of reasons. First, many of the chemical elements involved in the best photovoltaic semiconductors are expensive and environmentally unfriendly. This removal subsequent to controlled deposition involves containment, dust and dirt collection and disposal, and possible cell contamination. This is not only wasteful but considerably adds to expense, 10 Secondly, the removal processes are difficult to control dimensionally. Thus a significant amount of the valuable photovoltaic semiconductor is lost to the removal process. Ultimate module efficiencies are further compromised in that the spacing between adjacent cells grows, thereby reducing 15 the effective active collector area for a given module area.

Thus there remains a need for an inexpensive manufacturing process which allows high heat treatment for thin film photovoltaic junctions while also offering unique means to achieve effective integrated series connections.

A further unsolved problem which has thwarted production of expansive surface photovoltaic modules is that of collecting the photogenerated current from the top, light incident surface. Transparent conductive oxide (TCO) layers those TCO layers are relatively resistive compared to pure metals. This fact forces individual cell widths to be reduced in order to prevent unacceptable resistive power losses. As cell widths decrease, the width of the area between individual cells (interconnect area) should also decrease so that the 30 relative portion of inactive surface of the interconnect area does not become excessive. Typical cell widths of one centimoter are often taught in the art. These small cell widths demand very fine interconnect area widths, which dietate connect the top TCO surface of one cell to the buttom electrode of an adjacent series connected cell. Furthermore, achieving good stable ohmic contact to the TCO cell surface has proven difficult, especially when one employs those sensitive techniques available when using the TCO only as the 40 top collector electrode. The problem of collecting photovoltaic generated current from the top light impinging surface of a photovoltaic cell has been addressed in a mimber of ways, none entirely successful.

in a somewhat removed segment of technology, a number 45 of electrically conductive fillers have been used to produce electrically conductive polymeric materials. This technology generally involves mixing of the conductive filler into the polymer resin prior to l'abrication of the material into its final shape. Conductive fillers typically consist of high aspect ratio 50 particles such as metal fibers, metal flakes, or highly structured carbon blacks, with the choice based on a number of cost/performance considerations. Electrically conductive resins have been used as bulk thermoplastic compositions, or formulated into paints. Their development has been spurred 55 in large part by electromagnetic radiation shielding and static dischange requirements for plastic components used in the electronics industry. Other known applications include resistive heating fibers and battery components.

by yet another separate technological segment, electroplat- 60 ing on plastic substrates has been employed to achieve decorative effects on items such as knobs, cosmetic closures, laucets, and automotive trim. ABS (acrylonitrile-butadienestyrene) plastic dominates as the substrate of choice for most applications because of a blend of mechanical and process 65 properties and ability to be uniformly ciched. The overall platting process comprises many steps. First, the plastic sub

strate is chemically etched to microscopically roughen the surface. This is followed by depositing an initial metal layer by chemical reduction (typically referred to as "electroless plating"). This initial metal layer is normally copper or nickel of thickness typically one-half micrometer. The object is then electroplated with metals such as bright nickel and chromium to achieve the desired thickness and decorative effects. The process is very sensitive to processing variables used to fabricate the plastic substrate, limiting applications to carefully molded parts and designs. In addition, the many steps employing harsh chemicals make the process intrinsically costly and environmentally difficult. Finally, the sensitivity of ABS plastic to liquid hydrocarbons has prevented certain applications. The conventional technology for electroplating on plastic (etching, chemical reduction, electroplating) has been extensively documented and discussed in the public and commercia) literature. See, for example, Saubestre, Transactions of the Institute of Motal Finishing, 1969, Vol. 47., or Arcilesi et al., Products Finishing, March 1984.

A mumber of attempts have been made to simplify the electroplating of plastics. If successful such efforts could result in significant cost reductions for electroplated plastics and could allow facile continuous electroplating of plastics to be practically employed, thus permitting new applications. have been employed as a top surface electrode. However, 25 Some simplification altempts involve special chemical techniques, other than conventional electroless metal deposition, to produce an electrically conductive film on the surface. Typical examples of the approach are taught by U.S. Pat. No. 3,523,875 to Minklei, U.S. Pat. No. 3,682,786 to Brown et al., and U.S. Pat. No. 3,619,382 to Lupinski. The electrically conductive surface film produced was intended to be electroplated. Multiple performance problems thwarfed these attempts.

Other approaches contemplate making the plastic surface delicate and sensitive techniques to be used to electrically 35 itself conductive enough to allow it to be electroplated directly thereby avoiding the "electroless plating" or lamination processes. Efforts have been made to advance systems contemplating metal electrodeposition directly onto the surface of polymers made conductive through incorporating conductive fillers. When considering polymers rendered electrically conductive by loading with electrically conductive fillers, it may be important to distinguish between "microscopic resistivity" and "bulk" or macroscopic resistivity". "Microscopic resistivity" refers to a characteristic of a polymer/filler mix considered at a relatively small linear dimension of for example 1 micronetter or less. "Bulk" or "macroscopic resistivity" refers to a characteristic determined over larger linear dimensions. To illustrate the difference between "microscopic" and "bulk, macroscopic" resistivities, one can consider a polymer loaded with conductive fibers at a fiber loading of 10 weight percent. Such a material might show a low "bulk, macroscopic" resistivity when the measurement is made over a relatively large distance. However, because of fiber separation (holes) such a composite might not exhibit consistent "microscopic" resistivity. When producing an electrically conductive polymer intended to be electroplated, one should consider "microscopic resistivity" in order to achieve uniform, "hole-free" deposit coverage. Thus, it may be advantageous to consider conductive fillers comprising those that are relatively small, but with loadings sufficient to supply the required conductive contacting. Such fillers include metal powders and flake, metal coated mica or spheres, conductive carbon black, conductive nanoparticle materials, subdivided conductive polymers and the like.

Efforts to produce electrically conductive polymers suitable for direct electroplating have encountered a number of obstacles. The first is the combination of fabrication difficulty

and material property deterioration brought about by the heavy filler loadings often required. A second is the high cost of many conductive fillers employed such as silver flake.

Another obstacle involved in the electroplating of electrically conductive polymers is a consideration of adhesion 5 between the electrodeposited metal and polymeric substrate (metal/polymer adhesion). In some cases such as electroforming, where the electrodeposited metal is eventually removed from the substrate, metal/polymer adhesion may actually be detrimental. However, in most cases sufficient to adhesion is required to prevent metal/polymer separation during extended environmental and use cycles.

A number of methods to enhance adhesion have been employed. For example, etching of the surface prior to plating can be considered. Etching can often be achieved by immer- 15 sion in vigorous solutions such as chromic/sulfinic acid. Alternatively, or in addition, an etchable species can be incorporated into the conductive polymeric compound. The etchable species at exposed surfaces is removed by immersion in an etchant prior to electroplating. Oxidizing surface (reat- 20 ments can also be considered to improve metal/plastic adhe sion. These include processes such as flame or plasma treatments or immersion in oxidizing acids.

In the case of conductive polymers containing finely divided metal, one can propose achieving direct metal-to- 25 metal adhesion between electrodeposit and filler. However, here the metal particles are generally encapsulated by the rosin binder, often resulting in a resin rich "skin". To overcome this effect, one could propose methods to remove the "skin", exposing active metal filler to bond to subsequently 30 electrodeposited metal

Another approach to impart adhesion between conductive resin substrates and electrodeposits is incorporation of an "adhesion promoter" at the surface of the electrically conductive resin substrate. This approach was taught by Chien et al., 35 in U.S. Pat. No. 4,278,510 where maleic anhydride modified propylene polymers were taught as an adhesion promoter. Luch, in U.S. Pat. No. 3,865,699 taught that certain sulfur bearing chemicals could function to improve adhesion of initially electrodeposited Group VIII metals

An additional major obstacle confronting development of electrically conductive polymeric resin compositions capable of being directly electroplated is the initial "bridge" of electrodeposit on the surface of the electrically conductive resin. In electrodeposition, the substrate to be plated is often made 45 cathodic through a pressure contact to a metal contact tip. itself under cathodic potential. However, if the contact resistance is excessive or the substrate is insufficiently conductive, the electrodeposit current favors the metal contact and the electrodeposit may have difficulty bridging to the substrate, 50 The "bridging" problem extends to substrates having low surface corrent carrying capacity such as vacuum metallized or electrolessly plated films. In some cases, "burning" or actual "deplating" of very thin metal deposits can be experienced during the initial moments of "bridge" formation.

Moreover, a further problem is encountered even if specialized racking or contacting successfully achieves electrodeposit bridging to the substrate. Many of the electrically conductive polymeric resins have resistivities far higher than the electroplating of conductive ink patterns or thin metal films, the conductive material may be relatively thin. The initial conductive substrate can be relatively limited in the amount of electrodeposition current which it alone can convey. In these cases the initial conductive substrate may not 65 cover almost instantly with electrodeposit as is typical with thicker metallic substrates. Rather the electrodeposit cover-

age may result from lateral growth over the surface, with a significant portion of the electrodeposition current, including that associated with the lateral electrodeposit growth, passing through the previously electrodeposited metal. This restricts the size and "growth length" of the substrate conductive pattern, increases pisting costs, and can also result in large nonuniformities in electrodeposit integrity and thickness over the nattern.

Rates of this lateral growth likely depend on the ability of the substrate to convey current. Thus, the thickness and resistivity of the initial conductive substrate can be defining factors in the ability to achieve satisfactory electrodeposit coverage rates. When dealing with extended electroplated patterns, long narrow metal traces are often desired, deposited on relatively thin initial conductive substrates such as printed inks. These factors of course work against achieving the desired result.

This coverage rate problem likely can be characterized by a continuum, being dependent on many factors such as the nature of the initially electrodeposited metal, applied voltage, electroplating bath chamistry, the nature of the polymeric binder and the resistivity of the electrically conductive polymeric substrate. As a "rule of thumb", the instant inventor estimates that coverage rate problems would demand attention if the resistivity of the conductive polymeric substrate rose above about 0.001 ohm-cm. Alternatively, electrical current carrying capacity of thin films is often reported as a surface resistivity in "ohms per square". Using this measure, the inventor estimates that coverage rate issues may demand attention should the surface resistivity rise above about 0.01 ohms per square.

Beset with the problems of achieving adhesion and satisfactory electrodeposit coverage rates, investigators have attempted to produce directly electroplateable polymers by heavily loading polymers with relatively small conductive filler particles. Fillers include finely divided metal powders and flake, conductive metal oxides and intrinsically conductive polymers. Heavy loadings may be sufficient to reduce both microscopic and macroscopic resistivity to levels where the coverage rate phenomenon may be manageable. However, attempts to make an acceptable directly electroplateable resin using the relatively small fillers alone encounter a number of barriers. First, the fine conductive fillers can be relatively expensive. The loadings required to achieve the particle-to-particle proximity to achieve acceptable conductivity increases the cost of the polymer/filler blend dramatically. The fine fillers may bring further problems. They tend to cause deterioration of the mechanical properties and processing characteristics of many resins. This significantly limits options in resin selection. All polymer processing is best achieved by formulating resins with processing characteristics specifically tailored to the specific process (injection molding, extrusion, blow molding, printing, etc.). A required heavy loading of filler severely restricts ability to manipulate 55 processing properties in this way. A further problem is that metal fillers can be abrasive to processing machinery and may require specialized screws, barrels, and the like. Finally, despite being electrically conductive, a polymer filled with conductive particles still offers no mechanism to produce those of typical metal substrates. Also in many cases, such as an adhesion of an electrodeposit since the particles may be essentially encapsulated by the resin binder, often resulting in a non-conductive or non-hinding resin-rich "skin".

For the above reasons, fine conductive particle containing plastics have not been widely used as bulk substrates for directly electroplateable articles. Rather, they have found applications in production of conductive adhesives, pastes. and inks. Recent activity has been reported wherein polymer

inks heavily loaded with silver particles have been proposed as a "seed layer" upon which subsequent electrodoposition of metal is achieved. However, high material costs, application complexity, electrodeposit growth rate issues and adhesion remain with these approaches. In addition, it has been b reported that these films are typically deposited at a thickness of approximately 3 microns resulting in a surface resistance of approximately 0.15 ohms per square. Such low current carrying capacity films likely would experience the electroplating problems discussed above.

The least expensive (and least conductive) of the readily available conductive fillers for plastics are earbon blacks. Typically the resistivity of a conductive polymer is not alone. Thus in a thin film form at a thickness of 5 microns a surface resistivity would typically be approximately 2,000 ohms per square. Attempts have been made to produce electrically conductive polymers based on carbon black loading approach are the teachings of U.S. Pat. Nos. 4,038,042, 3,865, 699, and 4,278,510 to Adelman, Luch, and Chien et al. respectively.

Adelman taught incorporation of conductive carbon black into a polymeric matrix to achieve electrical conductivity required for electroplating. The substrate was pre-etched in chromic/sulfuric acid to achieve adhesion of the subsequently electroplated metal. However, the rates of electrodeposit coverage reported by Adelman may be insufficient for many suitable. applications.

Luch in U.S. Pat. No. 3,865,699 and Chien et al. in U.S. Pat. 4,278,530 also chose carbon black as a filler to provide an electrically conductive surface for the polymeric compounds to be electroplated. The Luch Patent 3,865,699 and the Chien 35 Patent 4,278,510 are hereby incorporated in their entirety by this reference. However, these inventors further taught inclusion of an electrodeposit coverage or growth rate accelerator to overcome the galvanic bridging and lateral electrodeposit growth rate problems described above. An electrodeposit 40 coverage rate accelerator is an additive functioning to increase the electrodeposition coverage rate over and above any affect it may have on the conductivity of an electrically conductive polymer. In the embodiments, examples and teachings of U.S. Pat. Nos. 3,865,699 and 4,278,510, it was 45 shown that certain suffer bearing materials, including elemental sulfur, can function as electrodoposit coverage or growth rate accelerators to overcome those problems associated with electrically conductive polymeric substrates having relatively high resistivity.

In addition to elemental sulfur, solfur in the form of sulfur donors such as sulfur chloride, 2-mercapto-benzothiazole, N-cyclohexyle-2-benzothiaozole sulfonomide, dibutyl xanthogen disulfide, and tetramethyl thirram disulfide or comthe art will recognize that these suffur donors are the materials which have been used or have been proposed for use as vulcanizing agents or accelerators. Since the polymer-based compositions taught by Luch and Chien et al. could be electroplated directly they could be accurately defined as directly 60 electroplateable resins (DER). These DER materials can be generally described as electrically conductive polymers charactorized by having an electrically conductive surface with the inclusion of an electrodeposit coverage rate accelerator. In the following, the acronym "DER" will be used to designate 65 a directly electroplateable resin as defined in this specification.

Specifically for the present invention, directly electroplateable resins, (DER), are characterized by the following fea-

- (a) presence of an electrically conductive polymer characterized by having an electrically conductive surface;
- (b) presence of an electrodeposit coverage rate accelerator; (c) presence of the electrically conductive polymer characterized by having an electrically conductive surface and the electrodeposit coverage rate accelerator in the directly electroplateable composition in cooperative amounts required to achieve direct coverage of the composition with an electrodeposited metal or metal-based

In his Patents, Luch specifically identified elastomers such reduced below approximately 1 ohm-cm using carbon black 15 as natural rubber, polychloroprene, butyl rubber, chlorinated butyl rubber, polybutadiene rubber, acrylonitrile-butadiene rubber, styrene-butadiene mbber etc. as suitable for the matrix polymer of a directly electroplateable resin. Other polymers identified by Luch as useful included polyvinyls, intended to be subsequently electroplated. Examples of this 20 polyolofins, polystyrenes, polyamides, polyesters and poly-

In his Patents, Luch identified carbon black as a means to render a polymer and its surface electrically conductive. As is known in the art, other conductive fillers can be used to impart conductivity to a polymer. These include metallic flakes or powders such as those comprising nickel or silver. Other fillers such as metal coated minerals and certain metal oxides may also suffice. Furthermore, one might expect that compusitions comprising intrinsically conductive polymers may be

Regarding electrodoposit coverage rate accelerators, both Luch and Chien et al. in the above discussed U.S. Patents demonstrated that sulfur and other sulfur bearing materials such as sulfur donors and accelerators served this purpose when using an initial Group VIII "strike" layer. One might expect that other elements of Group 6A nonmetals, such as oxygen, selenium and tellurium, could function in a way similar to sulfur. In addition, other combinations of electrodeposited metals and nonmetal coverage rate accelerators may be identified. Finally, the electrodeposit coverage rate accelerator may not necessarily be a discrete material entity. For example, the coverage rate accelerator may consist of a functional species appended to the polymeric binder chain or a species adsorbed onto the surface of the conductive filler. It is important to recognize that such an electrodeposit coverage rate accelerator can be extremely important in order to achieve direct electrodoposition in a practical way anto polymeric substrates having low conductivity or very thin electrically conductive polymeric substrates having restricted cor-50 rent carrying ability,

As pointed out above in this specification, attempts to dramatically simplify the process of electroplating on plastics have met with commercial difficulties. Nevertheless, the current inventor has persisted in personal efforts to overcome binations of these and sulfur were identified. Those skilled in ss certain performance deficiencies associated with electroplating onto material structures having low current carrying ability, conductive plastics and DER's. Along with these efforts has come a recognition of unique and eminently suitable applications for electrically conductive polymers and often more specifically the DER technology. Some examples of these unique applications for electroplated items include solar cell electrical current collection grids and interconnect structures, electrical circuits, electrical traces, circuit boards, autennas, capacitors, induction heaters, connectors, switches, resistors, inductors, batteries, fuel cells, coils, signal lines, power lines, radiation reflectors, confers, diodes, transistors. piezoelectric elements, photovoltaic cells, emi shields, biosensors and sensors. One readily recognizes that the demand for such functional applications for electroplated articles is relatively recent and has been particularly explosive during the next decade.

Regarding the DER technology, a first recognition is that 5 the "microscopic" material resistivity generally is not reduced below about 1 ohm-cm, by using conductive carbon black alone. This is several orders of magnitude larger than typical metal resistivities. Other well known finely divided conductive fillers (such as metal flake or powder, metal coated 10 minerals, graphite, or other forms of conductive carbon) can be considered in DER applications requiring lower "microscopie" resistivity. In these cases the more highly conductive litlers can be considered to augment or even replace the conductive carbon black.

Morcover, the "bulk, macroscopic" resistivity of conductive carbon black filled polymers can be further reduced by are menting the carbon black filler with additional highly conductive, high aspect ratio fillers such as metal containing fibers. This can be an important consideration in the success 20 of certain applications such as achieving higher current carrying capacity for a buss. Furthermore, one should realize that incorporation of non-conductive fillers may increase the "bulk, macroscopic" resistivity of conductive polymers landed with finely divided conductive filters without signifi- as cantly altering the "microscopic resistivity" of the conductive polymer. This is an important recognition regarding DER's in that electrodeposit coverage speed depends on the presence of an electrodeposit coverage rate accelerator and on the "microscopic resistivity" and less so on the "macroscopic resistiv- 30 ity" of the DER formulation. Thus, large additional loadings of functional non-conductive lillers can be tolerated in DER formulations without undue sacrifice in electrodeposit coverago rates or adhesion. These additional non-conductive loadings do not greatly affect the "microscopic resistivity" asso- 35 ciated with the polymer/conductive filler/electrodenosit coverage rate accelerator "matrix" since the non-conductive filler is essentially encapsulated by "matrix" material. Conventional "electroless" plating technology does not permit this compositional flexibility,

Yet another recognition regarding the DER technology is its ability to cuploy polymer resins and formulations generally chosen in recognition of the fabrication process envisioned and the intended end use requirements. In order to provide clarity, examples of some such fabrication processes 45 are presented immediately below in subparagraphs 1 through

- (1) Should it be desired to electroplate an ink, paint, conting, or paste which may be printed or formed on a substrate, a good film forming polymer, for example a soluble resin such as an elastomer, can be chosen to fabricate a DFR ink (paint, coating, paste etc.). The DER ink composition can be tailored for a specific process such flexographic printing, rotary silk screening, gravine printing, flow coating, spraying etc. Furthermore, 55 additives can be employed to improve the adhesion of the DER ink to various substrates. One example would be tackfieres.
- (2) Should it be desired to electroplate a fabric, a DER, ink can be used to coat all or a portion of the fabric intended 60 to be electroplated. Furthermore, since DER's can be fabricated out of the thermoplastic materials commonly used to create fabrics, the fabric itself could completely or partially comprise a DER. This would eliminate the need to coat the fabric.
- (3) Should one desire to electroplate a thermoformed article or structure, DER's would represent an environmently

suitable material choice. DER's can be easily formulated using olefinic materials which are often a preferred material for the thermoforming process. Purthermore, DER's can be easily and inexpensively extruded into the sheet like structure necessary for the thermoforming process.

(4) Should one desire to electroplate an extruded article or structure, for example a sheet or film, DER's can be formulated to possess the necessary melt strough advantageous for the extrusion process.

(5) Should one desire to injection mold an article or structure having thin walls, broad surface areas etc. a DER composition comprising a high flow polymer can be chosen.

(6) Should one desire to vary adhesion between an electrodeposited DER structure supported by a substrate the DER material can be formulated to supply the required adhesive characteristics to the substrate. For example, the polymer chosen to fabricate a DER ink can be chosen to cooperate with an "ink adhesion promoting" surface treatment such as a material primer or corona treatment. In this regard, it has been observed that it may be advantageous to limit such adhesion promoting treatments to a single side of the substrate. Treatment of both sides of the substrate in a roll to roll process may adversely affect the surface of the DER material and may lead to deterinration in plateability. For example, it has been observed that primers on both sides of a roll of PET film have adversely affected plateability of DER inks printed on the PET. It is believed that this is due to primer being transferred to the surface of the DER ink when the PET is rolled up.

All polymer fabrication processes require specific resin processing characteristics for success. The ability to "custom formulate" DER's to comply with these changing processing and end use requirements while still allowing facile, quality electroplating is a significant factor in the teachings of the current invention. Conventional plastic electroplating technology does not permit great flexibility to "custom formulate".

Another important recognition regarding the suitability of DER's for the teachings of the current invention is the samplicity of the electroplating process. Unlike many conventional electroplated plastics, DER's do not require a significant number of process steps during the manufacturing process. This allows for simplified manufacturing and improved process control. It also reduces the risk of cross contamination such as solution dragout from one process bath being, transported to another process bath. The simplified manufacturing process will also result in reduced manufacturing process.

Yet another recognition of the benefit of DER's for the teachings of the current invention is the ability they offer to selectively electroplate an article or structure. As will be shown in later embediments, it is often desired to electroplate a polymer or polymer based structure in a selective manner. DER's are eminently suitable for such selective electroplat-

Yet another recognition of the benefit of DER's for the teachings of the current invention is their ability to withstand the pre-treatments often required to prepare other materials for plating. For example, were a DER to be combined with a metal, the DIR material would be resistant to many of the pre-treatments such as cleaning which may be necessary to electroplate the metal.

Yet another recognition of the benefit of DER's for the teachings of the current invention is that the desired plated

structure often requires the plating of long and/or broad surface areas. As discussed previously, the coverage rate accelerators included in DER formulations allow for such extended surfaces to be covered in a relatively rapid manner thus allowing one to consider the use of electroplating of sconductive polymers.

These and other attributes of DER's in the practice of the instant invention will become clear through the following remaining specification, accompanying figures and claims.

In order to eliminate ambiguity in terminology, for the 10 present invention the following definitions are supplied:

"Meta)-based" refers to a material or structure having at least one metallic property and comprising one or more components at least one of which is a metal or metal-containing allow.

"Alloy" refers to a substance composed of two or more intimately mixed materials.

"Group VIII metal-based" refers to a substance containing by weight 50% to 100% metal from Group VIII of the Periadic Table of Elements.

"Electroplateable material?" refers to a material that exhibits a surface that can be exposed to an electroplating process to cause the surface to cover with electrodeposited material.

OBJECTS OF THE INVENTION

An object of the invention is to eliminate the deficiencies in the prior art methods of producing expansive area, series interconnected photovoltaic arrays.

A further object of the present invention is to provide 30 improved processes whereby expansive area, interconnected photovoltaic arrays can be economically mass produced.

A further object of the invention is to provide improved processes and structures for supplying current collector grids and interconnection structures.

Other objects and advantages will become apparent in light of the following description taken in conjunction with the drawings and embodiments.

SUMMARY OF THE INVENTION

The current invention provides a solution to the stated need by producing the active photovoltaic film and interconnecting structure separately and subsequently combining them to produce the desired expansive interconnected array.

In one embodiment, the interennnect structure is laminated to the light incident surface of a photovoltaic cell. If desired the separately prepared note connection structure allows the photovoltaic junction to be produced in bulk. Furthermore, the junction can be produced with a wide variety of photovoltaic materials including but not limited to, single crystal silicon, polycrystaltine silicon, amorphous silicon, CIS, CIGS, cadmium telluride, copper sulfide, semiconductor inks, polymer based semiconductor rinks etc.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a top plan view of a structure forming a starting article for an embodiment of the invention.

FIG. 1A is a top plan view of another embodiment of a $_{60}$ starting article of the invention.

FIG. 2 is a sectional view taken substantially from the perspective of lines 2-2 of FIG. 1.

FIG. 2A is a sectional view taken substantially from the perspective of lines 2A-2A of FIG. 1A.

FIG. 2B is a sectional view showing a possible structure of the article of FIGS. 1 and 2 in more detail.

PIG. 3 is a sectional view showing another embodiment of the basic structure depicted in FIG. 2.

FIG. 4 is a top plan view showing the initial article depicted in FIG. 1 following an additional processing step.

FIG. 5 is a sectional view taken substantially from the perspective of lines 5-5 of FIG. 4.

FIG. 6 is an exploded sectional view of the encircled region of FIG. 5 identified as 6-6.

FIG. 7 is a sectional view of the article of FIGS. 4 through 6, taken from a similar perspective of FIG. 5, showing the FIGS. 4 through 6 embodiment following an additional optional processing step.

FIG. 8 is an exploded sectional view of the encircled region of FIG. 7 identified as 8-8.

FIG. 9 is a top plan view of a photovoltaic cell useful in the practice of the invention.

FIG. 10 is a sectional view taken substantially from the perspective of lines 10-10 of FIG. 9.

FIG. 11 is an exploded sectional view showing the detail of the structure identified as layers 70 and 86 in FIG. 10.

FIG. 12 is a simplified depiction of one form of process possible in the manufacture of the article embodied in FIGS. 9 and 10.

FIG. 13 is a sectional view showing one embodiment of an arrangement appropriate to combine the articles of FIG. 7 with the article of FIG. 9 and 10 to achieve a series inter-connected photovoltaic assembly.

DESCRIPTION OF PREFERRED EMBODIMENTS

Reference will now be made in detail to the preferred embodiments of the invention, examples of which are illustrated in the accompanying drawings. In the drawings, like reference numerals designate identical or corresponding parts throughout several views and an additional letter designation is characteristic of a particular embodiment.

Referring now to FIGS, I (brough 3, there are shown 40 embodiments of a starting structure for a grid/interconnect article of the invention. FIG. 1 is a top plan view of a polymeric film or glass article generally identified by numeral 19. Article 10 has width X-10 and length Y-10. Length Y-10 is sometimes much greater the width X-10 such that article 10 can be processed in essentially a "roll-to-roll" fashion. However, this is not necessarily the case. Dimension "Y" can be chosen according to the application and process envisioned. FIG. 2 is a sectional view taken substantially from the perspective of lines 2-2 of FIG. 1. Thickness dimension Z-10 is normally small in comparison to dimensions Y-10 and X-10 and thus article 10 has a sheeflike structure. Article 10 is further characterized by having régions of essentially solid structure combined with regions having holes 12 extending through the thickness Z-10. In the FIG. 1 embodiment, 8 55 substantially solid region is generally defined by a width We, representing a corrent collection region. The region with through-holes (holey region) is generally defined by width Wi, representing an interconnection region. Imaginary line 11 separates the two regions. The reason for these distinctions and definitions will become clear in light of the following teachings.

FIGS. 1A and 2A is another embodiment of a sheetlike structure similar to that embodied in FIGS. 1 and 2 but absent the through holes present in the interconnection region Wi of the embodiment of FIGS. 1 and 2.

The instant invention will be taught using the structure embodied in FIGS. 1 and 2. However, one skilled in the art

will readily recognize application of the teachings to the structure embedied in FIGS, 1A and 2A and other equivalent structures when appropriate.

Referring now to FJG. 2, article 10 has a first surface 20 and second surface 22. The sectional view of article 10 shown in FIG. 2 shows a single layer structure. This depiction is suitable for simplicity and clarity of presentation. Often, however, article 10 will be a laminate comprising multiple layers as depicted in FIG. 2B. In the FIG. 2B embodiment, article 10 is seen to comprise multiple layers 14, 16, 18, etc. The multiple layers may comprise inorganic or organic components such as thermoplastics, thermosets, or silicon containing plass-like layers. The various layers are intended to supply functional attributes such as environmental barrier protection or adhesive characteristics. Such functional layering is well known and widely practiced in the plastic food packaging art. In particular, in light of the teachings to follow, one will recognize that it may be advantageous to have layer 14 forming spr face 20 comprise a sealing material such as an ethylene vinyl acetate (EVA) containing material for adhesive charac- 20 teristics during a possible subsequent lamination process. For example, the invention has been successfully demonstrated using a standard laminating material sold by GBC Corp., Northbrook, III., 60062. Additional layers 16, 18 etc. may comprise materials which assist in support or processing such 25 as polypropylene and polyerhylene terepthalate and barrier materials such as fluorinated polymers

As depicted in the curbodiments of FIGS. I and 2, the solid regions We and "holey" regions Wi of article 10 comprise the same material. This is not necessarily the case. For example, the "holey" regions Wi of article 10 could comprise a fabric, wowen or non-woven, joined to an adjacent substantially solid region along imaginary line 11. However, the materials forming the solid region should be relatively transparent or translucent to visible light, as will be understood in light of the teachings to follow.

PIG. 3 depicts an embodiment wherein multiple widths that the additional processing has deposited highly conductive instancial professions and 2 are jained together in a generally repetitive pattern in the width direction. As will become clear by the following teachings, such a structure may be advantageous in certain applications of photovoltaic cell interconnection.

FIG. 4 is a plan view of the FIG. 1 structure 10 following an additional processing step, and FIG. 5 is a sectional view 45 taken along line 5-5 of FIG. 4. In FIGS. 4 and 5, the article is now designated by the numeral 24 to reflect this additional processing. In FIGS. 4 and 5, it is seen that a pattern of "fingers" 26 has been formed by material 28 positioned in a pattern onto surface 20 of original article 10, "Fingers" 26 so extend over the width We of the solid sheetlike structure 24. The "fingers" 26 extend to the "holey" interconnection region generally defined by Wi. Portions of the We region not overlayed by "fingers" 26 remain transparent or translucent to visible light. The "fingers" may comprise electrically conduc- 55 tive material. Examples of such materials are metal containing inks, patterned deposited metals such as etched metal patterns, intrinsically conductive polymers and DER formulations. The "fingers" may comprise materials intended to facilitate subsequent deposition of conductive material in the 60 pattern defined by the fingers. An example of such a material would be ABS, which can be catalyzed to initiate chemical "electroless" metal deposition. In a preferred embodiment, the "fingers" comprise material which will enhance or allow subsequent metal electrodeposition such as a DER. In the 65 embodiment of FIGS. 4 and 5, the "fingers" are shown to be a single layer for simplicity of presentation. However, the

"fingers" can comprise multiple layers of differing materials chosen to support various functional attributes.

Continuing reference to FIGS. 4 and 5 also shows additional material 30 applied to the "holey" region Wi of article 24. As with the material comprising the "fingers" 26, the material 30 applied to the "holey" region Wis settler conductive or material intended to promote subsequent deposition of conductive material. In the embodiment of FIGS. 4 and 5, the "holey" region takes the general form of a "buss" 31 extending in the Y-24 direction in communication with the individual fingers. However, as one will understand through the subsequent teachings, the invention requires only that conductive communication extend from the lingers to a region Wi intended to be electrically joined to the electrode of an adjacticent cell. The "holey" region Wi thus does not require overall electrical continuity in the "Y" direction as is characteristic of a "buss" depicted in FIGS. 4 and 5.

Reference to FIG. 5 shows that the material 30 applied to the "holey" interconnection region W is shown as the same as that applied to form the fingers 26. However, these materials 28 and 30 need not be identical. In this embodiment material 30 applied to the "holey" region extends through holes 12 and not the opposite second surface 22 of article 24. This is host seen in FIG. 6, which is an exploded view of the portion of article 24 enterted by circle 6.6 of FIG. 5. The extension of material 30 through the holes 12 can be readily accomplished as a result of the relatively small thickness (Z dimension) of the sheetlike article. Techniques include two sided printing of conductive inks, through hole deposition of chemically (elsective inks and conductive polymers, and through hole electrodeposition.

FIG. 7 is a view similar to that of FIG. 5 following an additional optional processing step. FIG. 8 is an exploded view of the portion of FIG. 7 encircled there as 8-8. The article embodied in FIGS. 7 and 8 is designated by numeral 36 to reflect this additional processing. It is seen in FIGS. 7 and 8 that the additional processing has deposited highly conductive material 32 over the originally free surfaces of materials 28 and 30. Material 32 is normally metal-based such as copper or nickel, tin etc. Typical deposition techniques such as chemical or electrochemical metal deposition can be used for this additional optional process to produce the article 36. In a preferred embodiment, electrodeposition is chosen for its speed, eace, and cost effectiviness.

It is seen in FIGS. 7 and 8 that highly conductive material 32 extends through holes to electrically join and form electrically conductive surfaces on opposite sides of article 36. While shown as a single layer in the FIG. 7 and FIGS. 8 embodiment, the highly conductive material can comprise multiple layers to achieve functional value. In particular, a layer of copper is often desirable for its high conductivity. Nickel is often desired for its adhesion characteristics, plateability and corrosion resistance. The exposed surface 39 of material 32 can be selected for corrosion resistance and bonding ability. In particular, tin or tin containing alloys are a possible choice of material to form the exposed surface of material 32. Tin and tin containing alloys melt at relatively low temperatures, which may be desirable to promote ohmic joining to other components in subsequent processing such as lamination.

The structures and articles such as those embodied in FIGS. 4 though 8 are defined herein as forms of "interconnecting straps" or simply "straps".

Referring now to FIGS. 9 and 10, there is embodied a thin film photovoltaic cell generally identified by the numeral 40. Cell 40 has a light incident top surface 59 and a bottom

surface 66, Ceil 40 has a width X-40 and length Y 40. Width X-40 defines a first photovoltaic cell terminal edge 45 and second photovoltaic cell terminal edge 46. In some cases, particularly during initial cell manufacture, dimension Y-40 may be considerably greater than dimension X-40 such that cell 40 can generally be described as "continuous" or being able to be processed in a roll-to-roll fashion. However, this "continuous" characteristic is not a requirement for the instant invention. FIG. 10 shows that cell 40 comprises a thin film semiconductor structure 70 supported on metal-based 10 foil 72. Poil 72 has a first surface 74, second surface 76, and thickness Z-40. Metal-based foil 72 may be of uniform composition or may comprise a laminate of two or more metalbased layers. For example, foil 72 may comprise a base layer of inexpensive and processable material 78 with an additional 15 metal-based layer 81 disposed between base layer 78 and semiconductor material 70. The additional metal-based layer may be chosen to ensure good ohinic contact between the top surface 74 of foil 72 and semiconductor structure 70. Bottom surface 76 of foil 72 may comprise a material 79 chosen to 20 achieve good electrical and mechanical joining characteristics as will become clear in the subsequent teachings. The thickness 7-40 is often chosen such that cell 40 remains flexible for roll-to-roll handling and to minimize weight. However, the invention is not limited to flexible, lightweight 25 cells and the teachings contained herein can be applied to rigid cells such as those comprising glass substrates or superstrates or those comprising single crystal silicon cells.

Semiconductor structure 70 can be any of the photovoltaic and structures known in the art. Included are cells comprising single crystal silicon, pulycrystalline silicon, thin film cells such as those comprising CuS, CIS, CIGS and CdTe, and cells comprising polymer based semiconductors. In its simplest form, a photovoltaic cell combines an n-type semiconductor 35 with a p-type semiconductor to form an n-p junction. Most often an optically (ransparent window electrode, identified as 86 in FIG. 10, such as a thin film of zinc or tin oxide is employed to minimize resistive losses involved in current collection. FIG. 11 illustrates an example of a typical photovoltaic cell structure in section. In the figures, an arrow labeled "hv" is used to indicate the light incident side of the structure. In FIG. 11, 80 represents a thin film of a p type semiconductor, 82 a thin film of n-type semiconductor and 84 the resulting photovoltaic junction. Window electrode 86 45 completes the typical photovoltale structure.

FIG. 12 presents one method of manufacture of a foil supported photovoltaic structure such as embodied in FIGS, 9 and 10. The metal-based fail 72 is moved in the direction of its length Y through a deposition process, generally indicated by 50 ture. numeral 90. Process 90 accomplishes deposition of the active photovoltaic structure onto foil 72. Fuil 72 is unwound from supply rolf 92, passed through deposition process 90 and rewound onto takeup roll 94. Process 90 can comprise any of photovoltaic structures. These processes include electroplating, vacuum sputtering, and chemical deposition. Process 90 may also include treatments, such as heat treatments or slitting, intended to enhance performance or manufacturing abil-

One method of combining the interconnect "strans" embedded in FIGS, 4-6 and optionally in FIGS, 7 and 8 with the photovoltaic cells embodied in FIGS. 9 and 10 is illustrated in FIG. 13. In the FIG. 13 structure, individual straps 36a, 36b, 36c, are combined with cells 40a, 40b, 40c to form 65 a series interconnected array. This may be accomplished via the following process.

1. An individual strap, such as 36a, is combined with a cell such as 40a by positioning the free surface 20 of solid surface region We of strap 36a in registration with the light incident surface 59 of cell 40a. Adhesion joining the two surfaces is accomplished by a suitable process. It is envisioned that batch or continuous laminating processing, such as that widely used in the food packaging industry would be one suitable method to accomplish this surface joining. In particular, the material forming the remaining free surface 20 of article 36a (that portion of surface 20 not covered with conductive material 32) can be chosen to promote good adhesion between the sheetlike article 36a and cell 40a during a surface laminating process. Also, as mentioned above, the nature of the free surface of conductive material 32 may be manipulated and chosen to further guarantee of mic joining and adhesion. The laminating process brings the conductive material of fingers 26 into firm and effective contact with the transparent conductive material 86 forming surface 59 of cell 40a.

2. Subsequently or concurrently with Step 1, the conductive material 32 extending over the second surface 22 of strap 36h is obmicly adhered to the bottom surface 66 of cell 40a. This joining is accomplished by suitable electrical joining techniques such as soldering, riveting, spot welding or conductive adhesive application. The particular ofunic joining technique is not shown in the FIG. 13. However, a particularly suitable conductive adhesive is one based on a carbon black filler in a polymer matrix. Such adhesive formulations are relatively inexpensive. Despite the fact that carbon black formulations have relatively high intrinsic resistivities (of the order 1 oluncm.), the bonding in this embodiment is accomplished through a relatively thin adhesive layer and over a broad surface. Thus the resulting resistance losses are relatively limited. Strap 36h extends over the light incident surface of cell 40b

PIG. 13 embodies three cells assembled in a series arrangement using the teachings of the instant invention, in FIG. 13, "i" indicated the direction of net current flow. It is noted that the arrangement of FIG. 13 resembles a shingling arrangement of cells, but with an important distinction. The prior art shingling arrangements have included an overlapping of cells at a sacrifice of portions of very valuable cell surface. In the FIG. 13 teaching, the benefits of the shingling interconnec tion concept are achieved without any loss of photovoltaic surface from shading by an overlapping cell. In addition, the FIG. 13 arrangement retains a high degree of flexibility because there is no immediate overlap of the nuctal foil struc-

EXAMPLE

A standard plastic laminating sheet from GBC Corp. was the processes well-known in the art for depositing thin film 55 coated with DER in the pattern of repetitive fingers joined along one end with a busslike structure resulting in an article as embodied in FIGS. 4 through 6. The fingers were 0.020 inch wide, 1.625 inch long and were repetitively separated by 0.150 inch. The buss-like structure which contacted the fingers extended in a direction perpendicular to the lingers as shown in FIG. 4. The buss like structure structure had a width Wi of 0.25 inch. Both the finger pattern and buss-like structure were printed simultaneously using the same DER ink and using silk screen printing. The DER printing pattern was applied to the laminating sheet surface formed by the sealing layer (i.e. that surface facing to the inside of the standard sealing pouch).

The finger/biss pattern thus produced on the lamination sheet was then electroplated with nickel in a standard Warts nickel bath at a current density of 50 amps, per sq. ft. Approximately 4 micrometers of tickel thickness was deposited to the overall pattern.

A photovoltaic cell having surface dimensions of 1.75 inch wide by 2.0625 inch long was used. This cell was a CIGS semiconductor type deposited on a 0.001 inch stainless steel substrate. A section of the Immining sheet containing the electroplated boss/linger pattern was then applied to the top, to light incident side of the cell, with the electroplated grid finger extending in the width direction (1.75 inch dimension) of the cell. Care was taken to ensure that the buss or interconnect region, Wi, of the electroplated laminate did not overlap the cell surface. This resulted in a total cell surface of 15 3.61 sq. inch. (2.0625*x1.75**) with about 12% shading from the grid, (i.e. about 88% open area for the cell).

The electroplated "finger/buss" on the lamination film was applied to the photovollaic cell using a standard Xerox office laminator. The resulting completed cell showed good appearance and connection.

The cell prepared as above was tested in direct sunlight for photovoltaic response. Testing was done at noon, Morgan Hill, Calif. on April 8 in full sunlight. The cell recorded an open circuit voltage of 0.52 Volts. Also recorded was a "short 25 circuit" current of 0.65 Amp. This indicates excellent power collection from the cell at high efficiency of collection.

Although the present invention has been described in conjunction with preferred embodiments, it is to be understood that modifications, alternatives and equivalents may be so included without departing from the spirit and scope of the inventions, as those skilled in the art will readily understand. Such modifications, alternatives and equivalents are considered to be within the purview and scope of the invention and appended claims.

What is claimed is:

- A device comprising a first photovoltaic cell and an additional interconnection structure, wherein,
 - said photovoltaic cell comprises a cell body, suid body 40 comprising semiconductor material a light incident top cell surface formed by a transparent or translucent conductive material;
- said additional interconnection structure comprises a sheatlike substrate, having overlapping first and second substrate surfaces, said first substrate surface facing in a direction opposite and away from said second substrate surface;
- said interconnection structure further comprising a collection region and an interconnection region;
- said substrate comprising said collection region is transpurent or transfucent and has a pattern comprising electrically conductive material positioned over on said first substrate surface;
- anid interconnection region comprises additional electri- 55 cally conductive material positioned over portions of said second substrate surface, said additional electrically conductive material being in electrical communication with said pattern through an electrical path not traversing said semiconductor materials and.
- wherein said device comprises a combination of said photovoltaic celf and said interconnection structure sool, that said first substrate surface of said collection region constitute at and said light incident top cell surface face toward each other so that physical contact is made between the said pattern on the first substrate surface and the said light incident surface.

- 2. The device of claim 1 wherein said electrical communication between said additional conductive material and said pattern is established using holes extending through said substrate from said first surface to said second surface, and wherein electrically conductive material extends through said holes to electrically connect conductive material positioned on said first and second surfaces of said substrate.
- The device of claim 2 wherein said substrate comprises an electrically insulating layer of material, and wherein said holes extend through said insulating layer.
- 4. The device of claim 1 further comprising a second photovoltaic cell, said second cell having an electrically conductive bottom surface portion facing away from a light incident top cell surface, said second cell being positioned such that said conductive bottom surface portion of said second cell overlaps said interconnection region os said additional electrically conductive material positioned over said second surface within said interconnection region contacts said bottom conductive surface portion.
- 5. The device of claim 4 wherein there is substantially no overlap between said first and second photovoltaic cells.
- 6. The device of claim 4 wherein both said first and second cells have terminal edges defined by the extent of said semi-conductor material, said cells being interconnected in series, and wherein there is no substantial separation, in a direction parallel to said light incident surfaces of said cells, between adjacent terminal edges of said first and second cells required to achieve said series interconnection.
- 7. The device of claim 4 wherein both said first and second cells have terminal edges defined by the extent of said semi-conductor materiat, said first and second cells being interconnected in series, said device is capable of achieving said series connection without requiring either overlapping of said cells or substantial separation of adjacent terminal edges of said cells in a direction parallel to said light incident surfaces.
- The device of claim 4 wherein said electrically conductive bottom surface portion of said second cell comprises a metal foil.
- The device of claim 8 wherein said metal full comprises a laminate of multiple layers.
- The device of claim 8 wherein said metal foil is self supporting.
- The device of claim 10 wherein said meta) foil comprises stainless steel.
- The device of claim I wherein said sheetlike substrate comprises a silicon containing layer.
- The device of claim 1 wherein said pattern comprises an electrically conductive polymer.
- 14. The device of claim 1 wherein said pattern comprises polymeric material characterized as being able to facilitate deposition of metal.
- 15. The device of claim 1 wherein said pattern comprises a directly electroplateable resin (DER).
- 16. The device of claim 1 wherein said pattern comprises an electrodeposit.
- The device of claim 16, wherein said electrodeposit comprises copper.
- 18. The device of claim 1 wherein a portion of said electrically conductive material of the pattern and a portion of said additional conductive material of the interconnection region constitute a unmobilitie structure.
- 19. The device of claim 1 wherein said substrate comprises polymeric material.
- The device of claim 19 wherein said substrate comprises multiple polymeric layers.

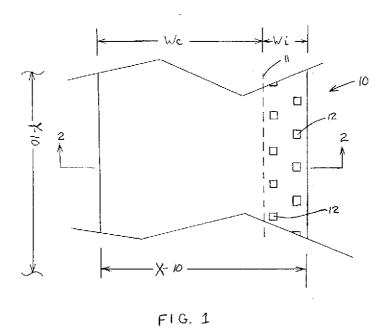
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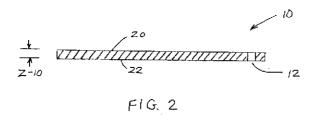
- The device of claim 1 wherein at least a portion of said first substrate surface comprising a material with adhesive characteristic relative to said light incident surface.
- The device of claim 21 wherein said material with adhesive characteristic comprising a laminating adhesive.
- 23. The device of claim 1 wherein said pattern comprises multiple substantially parallel fingers extending in a first direction.
- 24. The device of claim 23 wherein said fingers are substantially rectangular in their cross section.
- 25. The device of claim 23 wherein said additional electrically conductive material positioned over said second substrate surface extends, in a direction substantially perpendicular to said first direction spanning multiple said fingers.
- 26. The device of claim I wherein either of said pattern or 15 said additional electrically conductive material comprises printed material.
- 27. The device of claim 26 wherein said printed material comprises a homogeneous mixture of conductive particles in a polymer matrix.
- 28. The device of claim 26 wherein said printed material comprises silver or carbon black.
- 29. The device of claim 1 wherein either of said pattern or said additional electrically conductive material comprises metal with melting point of tin.
- 30. A device comprising multiple photovoltaic cells and an additional interconnection structure to achieve a series interconnection between two of said photovoltaic cells; wherein,
 - said two photovolatic cells each have a cell body, said body comprising a light incident top surface formed by a transparent or translucent conductive material and further comprising semiconductor material overlaying conductive material forming a conductive bottom surface,

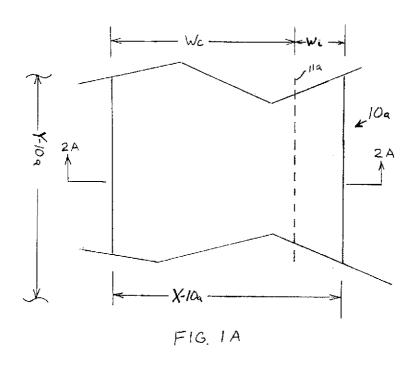
- said conductive bottom surface facing away from said light incident surface, said cell further comprising terminal edges defined by boundaries of said semiconductor material;
- said additional interconnection structure comprising,
 - a sheeflike substrate, said substrate having overlapping a first and second substrate surfaces, said first surface facing in a direction opposite and away from said second surface;
- said interconnection structure further comprising multiple structural portions, a first of said portions is transparent or translucent and has a first pattern comprising electrically conductive material positioned on said first surface, and a second of said portions has a second pattern comprising electrically conductive material positioned on said second surface, wherein said first and second patterns are in electrical communication;
- said first structural portion overlaying said light incident surface of a first of said cells such that said first substrate surface of said first portion and said light incident surface face each other and said first pattern contacts said light incident surface:
 - said second pattern and said conductive bottom surface of a second of said cells listing each other such that said second pattern is in contact with said bottom conductive surface of said second cell.
- 31. The device of claim 30 wherein said first and second patterns comprise a monolithic material forming portions of both said first and second patterns.
- 32. The device of claim 30 further comprising said second structural portion at least partially positioned outside a boundary terminal edge of first cell.

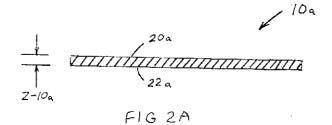
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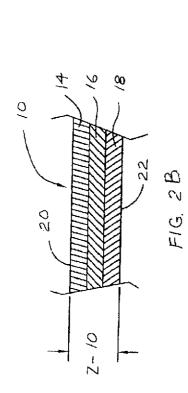


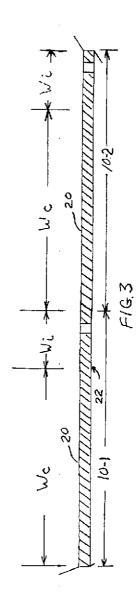






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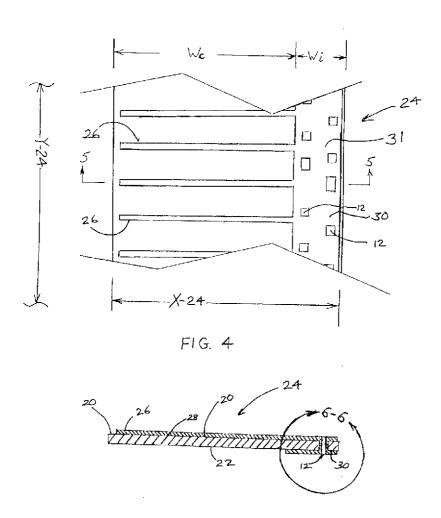
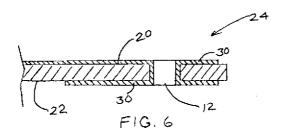
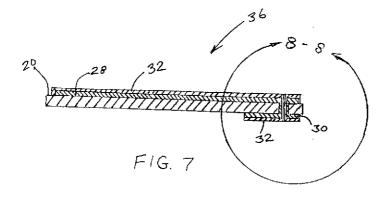
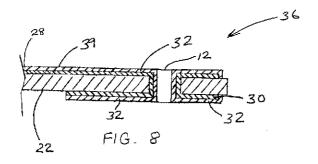
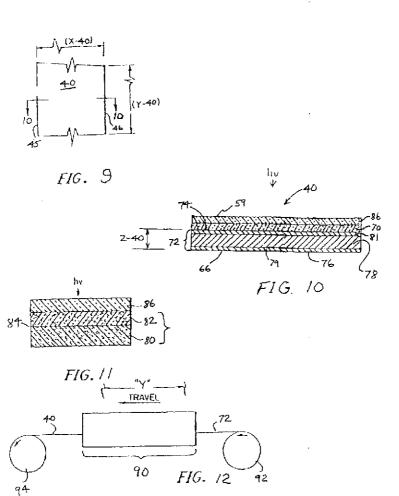


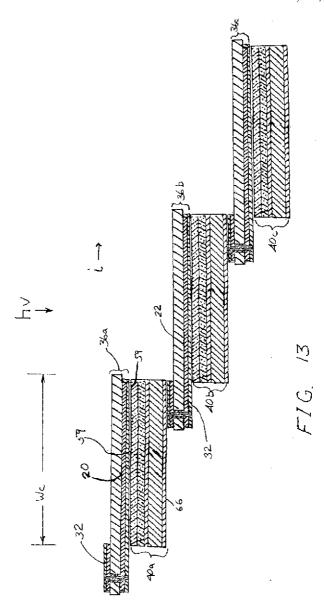
FIG. 5











SUBSTRATE AND COLLECTOR GRID STRUCTURES FOR INTEGRATED PHOTOVOLTAIC ARRAYS AND PROCESS OF MANUFACTURE OF SUCILARRAYS

CROSS RÉFERENCE TO RELATED APPLICATIONS

This application is a Continuation-in-Part of U.S. patent application Ser. No. 10/776,480 filed Feb. 11, 2004, now abandoned entitled Methods and Structures for the Continuous Production of Metallized or Electrically Treated Articles, which is a Continuation in Part of U.S. patent application Ser. No. 10/682,093 filed Oct. 8, 2003 entitled Substrate and Collector Grid Structures for Integrated Series Connected Photovoltaic Arrays and Process of Manufacture of Such Arrays, which is a Continuation-in-Part of U.S. patent application Ser. No. 10/186,546 filed Jul. 1, 2002, entitled Substrate and Collector Grid Structures for Integrated Series Connected Photovoltaic Arrays and Process of Manufacture of Such Arrays, and now ahandoned, which is a Continuationin-Part of U.S. patent application Ser. No. 09/528,086, filed Mar. 17, 2000, entitled Substrate and Collector Grid Structures for Integrated Series Connected Photovoltaic Arrays Pat. No. 6,414,235, which is a Contimistion-in-Part of U.S. patent application Scr. No. 09/281,656, filed Mar. 30, 1999, entitled Substrate and Collector Grid Structures for Electrically Interconnecting Photovoltaic Arrays and Process of Manufacture of Such Arrays, and now U.S. Pat. No. 6,239, 352. The entire contents of the above identified applications are incorporated herein by this reference.

BACKGROUND OF THE INVENTION

Photovoltaic cells have developed according to two distinct methods. The initial operational cells employed a matrix of single crystal silicon appropriately doped to produce a planar junction produces a voltage by directing solar photon produced holes and free electrons in opposite directions. Despite good conversion efficiencies and long-term reliability, widespread energy collection using single-crystal silicon cells is thwarted by the exceptionally high cost of single crystal sili- 45 con material and interconnection processing.

A second approach to produce photovoltaic cells is by depositing thin photovoltaic semiconductor films on a suppurting substrate. Material requirements are minimized and technologies can be proposed for mass production. The thin so film structures can be designed according to doped homojunction technology such as that involving silicon films, or can employ heterojunction approaches such as those using CdTe or chalcopyrite materials. Despite significant improvements in individual cell conversion officiencies for both 55 single crystal and thin film approaches, photovoltaic energy collection has been generally restricted to applications having low power requirements. One factor impeding development of bulk power systems is the problem of economically collecting the energy from an extensive collection surface. Pho- 60 tovoltaic cells can be described as high current, low voltage devices. Typically individual cell voltage is less than one volt. The current component is a substantial characteristic of the power generated. Efficient energy collection from an expansive surface must minimize resistive losses associated with 65 the high current characteristic. A way to minimize resistive losses is to reduce the size of individual cells and connect

them in series. Thus, voltage is stepped through each cell while current and associated resistive losses are minimized.

It is readily recognized that making effective, durable series connections among multiple small cells can be labori-5 ous, difficult and expensive. In order to approach economical mass production of series connected arrays of individual cells, a number of factors must be considered in addition to the type of photovoltaic materials chosen. These include the substrate employed and the process envisioned. Since thin films can be deposited over expansive areas, thin film technologies offer additional opportunities for mass production of interconnected arrays compared to inherently small, discrete single crystal silicon cells. Thus a number of U.S. Patents have issued proposing designs and processes to achieve series interconnections among the thin film photovoltaic cells. Many of these technologies comprise deposition of photovoltaic thin films on glass substrates followed by scribing to form smaller area individual cells. Multiple steps then follow to electrically connect the individual cells in series array. Examples of these proposed processes are presented in U.S. Pat. Nos. 4,443,651, 4,724,011, and 4,769,086 to Swartz. Turner et al. and Tanner et al. respectively. While expanding the opportunities for mass production of interconnected cell arrays compared with single crystal silicon approaches, glass and Process of Maunfacture of Such Arrays, and now U.S. 25 substrates must inherently be processed on an individual hatch basis.

More recently, developers have explored depositing wide area films using continuous roll-to-roll processing. This technotogy generally involves depositing thin films of photovoltaic material onto a continuously moving web. However, a challenge still remains regarding subdividing the expansive films into individual cells followed by interconnecting into a series connected array. For example, U.S. Pat. No. 4,965,655 to Grimmer et. al. and U.S. Pat. No. 4,697,041 to Okamiwa 35 feach processes requiring expensive laser scribing and interconnections achieved with laser heat staking. In addition, these two references teach a substrate of thin vacuum deposited metal on films of relatively expensive polymers. The electrical resistance of thin vacuum metallized layers signifip-n junction. An intrinsic electric field established at the p-n 40 cantly limits the active area of the individual interconnected cells.

> It has become well known in the art that the efficiencies of certain promising thin film photovoltaic junctions can be substantially increased by high temperature treatments. These treatments involve temperatures at which even the most heat resistant plastics suffer rapid deterioration, thereby requiring either ceramic, glass, or metal substrates to support the thin film junctions. Use of a glass or commic substrates generally restricts one to batch processing and handling difficulty. Use of a metal foil as a substrate allows continuous roll-to-roll processing. However, despite the fact that use of a metal foil allows high temperature processing in roll-to-roll fashion, the subsequent interconnection of individual cells effectively in an interconnected array has proven difficult, in part because the metal foil substrate is electrically conduct-

> U.S. Pat. No. 4,746,618 to Nath et al. teaches a design and process to achieve interconnected arrays using roll-to-roll processing of a metal web substrate such as stainless steel. The process includes multiple operations of cutting, selective deposition, and riveting. These operations add considerably to the final interconnected array cost.

> U.S. Pat. No. 5,385,848 to Grimmer teaches roll-to-roll methods to achieve integrated series connections of adjacent thin film photovoltaic cells supported on an electrically conductive metal substrate. The process includes mechanical or chemical etch removal of a portion of the photovoltaic semi-